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Date

: May 3, 2006

TO

Director, Office of Patent Publication

FROM

Office of Petitions

SUBJECT

: Withdrawal from Issue of Application No. 10/623,581

Applicant(s)

: Isamu Kobori et al

Application No. : 10/623,581

: July 22, 2003

The above-identified application has been assigned Patent No. 7,041,587 and an issue date of May 9, 2006.

It is hereby directed that this application be withdrawn from issue at the request of the applicant. Do not refund the issue fee.

The following erratum should be published in the Official Gazette if the above-identified application is published in the OG of May 9, 2006:

"All reference to Patent No. 7,041,587 to Isamu Kobori et al of Japan for METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM TRANSISTOR appearing in the Official Gazette of May 9, 2006 should be deleted since no patent was granted."

Petitions Examiner

Office of Petitions

Paul Harrison cc:

Deneise Boyd

Mary Louise McAskill

Niomi Farmer

Mary E. Johnson (Cookie

Duane Davis (CDS)